



IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Shoichi FURUHATA

Serial No.: 10/797,923

Filed: March 10, 2004

Title: SEMICONDUCTOR WAFER,  
SEMICONDUCTOR DEVICE, AND PROCESS  
FOR MANUFACTURING THE  
SEMICONDUCTOR DEVICE

Group Art Unit: 2826

Examiner: Thomas L. Dickey

Attorney Docket No.: FUJI:300

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I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Date: 03/30/05  
By: Marc A. Rossi

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
ALEXANDRIA, VA 22313-1450

**RESPONSE TO ELECTION / RESTRICTION**

Sirs:

In response to the Election / Restriction requirement dated March 04, 2005, applicants wish to elect Group II, claims 1 to 9 for prosecution.

Respectfully submitted,  
ROSSI, KIMMS & McDOWELL LLP

03/30/05-  
Date

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